



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isaac Ostrovsky, et al.
Appl. No. : 10/017,534
Filing Date : October 18, 2001
Title : **DIFFRACTION GRATING BASED INTERFEROMETRIC
SYSTEMS AND METHODS**
Group Art Unit : 2877
Examiner : Patrick J. Connolly
Docket No. : 701470.19 (formerly 265/222)

Mail Stop **NON FEE AMENDMENT**
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

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RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action mailed July 14, 2003, Applicants respond as follows:

Attorney Docket Number

Please note that our Attorney Docket Number has been changed to 701470.19.

Applicants respectfully request that this number be referenced in all future correspondence.

CERTIFICATE OF MAILING (37 CFR §1.8)

I hereby certify, pursuant to 37 CFR §1.8, that I have reasonable basis to expect that that this paper or fee (along with any referred to as being attached or enclosed) would be mailed or transmitted on or before the date indicated with the United States Postal Service with sufficient postage as first class mail on the date shown below in an envelope addressed to Commissioner for Patents, PO Box 1450, Alexandria, Virginia, 22313-1450.

Dated: September 18, 2003


Sally Hartwell

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